



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q76993

Sadayuki OHNISHI

Appln. No.: 10/646,709

Group Art Unit: 2814

Confirmation No.: 9821

Examiner: Phat X. CAO

Filed: August 25, 2003

For: SEMICONDUCTOR DEVICE WITH INTERLAYER DIELECTRIC FILM AND  
MANUFACTURING METHOD THEREOF

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated June 1, 2006, time for responding to which has been extended to November 1, 2006, please amend the above-identified application as follows on the accompanying pages.

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